

| | | | | | |
|-----------------------------------|--|--|----------------------------|---|-------------|
| Notice of References Cited | | | Application/Control No. | Applicant(s)/Patent Under Reexamination 10/751,096 LIN ET AL. | |
| | | | Examiner Hashem Farrokh | Art Unit 2187 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|--------------------|----------------|
| * | A | US-2003/0163663 A1 | 08-2003 | Aasheim et al. | 711/202 |
| * | B | US-6,385,744 B1 | 05-2002 | Ando et al. | 714/54 |
| * | C | US-6,535,949 B1 | 03-2003 | Parker, Kenneth W. | 711/103 |
| | D | US- | | | |
| | E | US- | | | |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| | | |
|---|---|---|
| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
| | U | |
| | V | |
| | W | |
| | X | |

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.